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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10047455	FILING DATE 01/15/2002	CLASS 257	SUBCLASS 19	GAU 2811	EXAMINER <i>Hu</i>
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9/25/503  
\*\*CONTINUING DATA VERIFIED:

\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
Verified and Acknowledged Examiners's initials		N00400/70013 RJP/RHW	
TITLE : Semiconductor structures including a gallium nitride material component and a silicon germanium component			
U.S.DEP.T. OF COMM./PAT.& TM-PTO-436L (Rev. 12-94)			

Best Available Copy

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL		Primary Examiner		
DISCLAIMER		Application Examiner		
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